

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Takeshi Nakamura et al.	Art Unit :	3729
Serial No. :	10/598,469	Examiner :	Minh Trinh
Filed :	May 17, 2007	Conf. No. :	5820
Title :	MULTILAYER SUBSTRATE MANUFACTURING METHOD		

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JANUARY 23, 2009

Please amend the above-identified application as follows: